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Formation of MoO_x barrier layer under atmospheric based condition to control MoSe₂ formation in CIGS thin film solar cell

As part of the device fabrication process, selenization step is required to crystallise the CIGS absorber layer. However, during high temperature selenization process, excessive formation of MoSe₂ can lead to delamination of the film and adverse effect on electrical properties of the solar cells. In this paper, a new method is proposed to form a Molybdenum Oxide (MoO_x) barrier layer in between of the Mo back contact using plasma jet under atmospheric based conditions. The effect of MoO_x compound (MoO₂ and MoO₃) towards the efficiency of the device is investigated. It has been proven that a thin layer of MoO_x barrier layer is able to control the formation of MoSe₂ effectively and provide a significant improvement in electrical properties of the devices. A power conversion efficiency of 5.24% with least efficiency variation across the champion device was achieved which demonstrates the importance of this methodology on small area devices.

Keywords: Copper Indium Gallium Selenide; CIGS thin film solar cells; MoO_x barrier layer; atmospheric plasma jet; MoSe₂

1. Introduction

Copper Indium Gallium Selenide (CIGS) has become one of the most promising absorber layer for thin film photovoltaic devices due to its high absorption coefficient for solar radiation and compatibility of its bandgap (1.6eV-1.0eV) [1]. With an impressive progression made in recent years, CIGS solar cells currently holds a record efficiency of 22.6% which is the highest efficiency for thin film solar cells approaching Si [2].

As part of the device fabrication process, deposition of a thin-film of CIGS absorber layer followed by a selenization step is required to obtain highly crystallised material. The molybdenum (Mo) back contact typically reacts partially with selenium (Se) to form an intermediate MoSe₂ layer at the Mo/CIGS interface during the selenization process [3], [4]. The MoSe₂ layer is believed to improve the adhesion between Mo and CIGS [5]–[7]. It forms

a back surface field which can hinder the recombination of electrons and holes due to MoSe₂ has a wider bandgap of 1.41eV than the CIGS absorber layer [8]–[10]. The MoSe₂ layer also creates a favourable ohmic-type contact with resistivities as low as $10^{-3} \Omega \text{ cm}$ at the Mo/CIGS interface [8], [11], [12].

However, during the high temperature selenization process (above 723K), the reaction between Mo and Se can cause Mo back contact to react fully with Se to form a thick layer of MoSe₂[3]. Excessive formation of MoSe₂ can lead to delamination of the film and adverse effect on open circuit voltage (V_{oc}) and Fill factor (FF) of the CIGS solar cells due to high resistance of the MoSe₂ [13], [14]. A thinner MoSe₂ layer can be achieved by reducing the selenization temperature and duration, but this may affect the crystallisation of the CIGS absorber layer. A barrier layer can be deposited in between of the Mo back contact to control the Se diffusion and the growth of MoSe₂ [15]–[17]. Molybdenum Nitride (MoN_x) or Molybdenum dioxide (MoO₂) thin films with a thickness of 10nm to 250nm formed under vacuum based condition was used as a barrier layer [17], [18]. However, vacuum based approaches are typically costly, consumes very high energy and possesses low material utilisation, whereas atmospheric based approaches offered low cost and uniform deposition on thin films [19]. In addition, the effect of the barrier layers has on the efficiency of the solar cell is yet to be determined.

Therefore, considering the above mentioned, this paper proposes a new method to form a Molybdenum Oxide (MoO_x) barrier layer in between of the Mo back contact using plasma jet under atmospheric based conditions. A thin MoO_x barrier layer is applied in order to control the thickness of MoSe₂ and also to improve the J-V characteristics of the devices. Two types of barrier layers were deposited under vacuum based (MoN_x) and atmospheric based conditions (MoO_x) upon comparison purposes. Each set of films were completed in devices and were characterised. The effect of the barrier layers has on the solar cell performance is also discussed.

2. Experimental details

2.1 Formation of the MoO_x barrier layer

The substrates used in this project were Molybdenum (Mo) coated soda lime glass (SLG) provided by AimCore Technology Co., Ltd. The substrates have a Mo thickness of ~600 nm with resistivity about $1.6 \times 10^{-5} \Omega \text{ cm}$. An atmospheric plasma jet was used to form the MoO_x barrier layer under room temperature. A 5cm x 5cm Molybdenum coated glass (MoC) was first placed on a moveable stage and using helium gas, the oxygen gas was confined into plasma state while flowing through the discharge section. The plasma then passes through the nozzle to oxidise the surface of the Molybdenum coated glass (MoC). The setup of the atmospheric plasma jet is shown in Figure 1. Two different sample sets were processed. During the first set, the oxidation cycle and oxygen flow rate were varied from 3 to 6 and 20 SCCM to 40 SCCM respectively while the helium gas flow rate and voltage applied remained constant. The four samples from the first phase will be further characterized to determine which parameters should be altered. For the second set of the samples, oxygen flow rate and the applied voltage were increased from 40 SCCM to 60 SCCM and from 13.4kV to 26.2kV respectively while the oxidation cycle and helium gas flow rate remained constant. The oxidizing conditions of the atmospheric plasma jet are shown in Table 1. Mo 3, Mo 4 and Mo 8 were shortlisted to be processed in the next stage in section 2.2.

Figure 1. Atmospheric Plasma Jet

Table 1: Atmospheric Plasma Jet Oxidizing Condition

2. 2 Deposition of the top layer Molybdenum back contact

After oxidizing the surface of the Molybdenum coated glass (MoC), an additional layer of Molybdenum back contact was deposited onto the selected samples (Mo 3, 4 and 8) by DC magnetron sputtering in a Nordiko DC magnetron sputtering system. The Mo target used in the Nordiko system which has a size of 300mm x 100mm with 99.99% purity was supplied by the Testbourne Ltd. The oxidized MoC samples were mounted on a six slotted (5cm x 5cm for six samples) sample holder ~10cm away from the target. The deposition was done at system base pressure of 1.6×10^{-6} Torr with Argon (Ar) gas flow rate of 2 SCCM. The power used was 1790 W and the working pressure applied was 1.4 mTorr. The deposition time for the top Mo layer was 2 min and during the deposition process, the sample holder was rotated at 3 revolutions per minute (rpm).

2. 3 Film preparation and selenization

The samples with top Mo layer (two 2.5cm x 2.5cm samples from each) were proceeded to a less aggressive selenization process (shorter selenization duration) inside a tube furnace to observe the performance of the MoO_x barrier layer. The two 2.5cm x 2.5cm samples were placed inside a graphite box with ~300 mg of selenium (Se) pellets. The tube furnace was first purge with nitrogen gas followed by setting up the starting pressure at 58.4kPa. The heating profile lasted for 30 min which resulted in complete evaporation of the Se pellets in the box.

The remaining two 2.5cm x 2.5cm samples were used as the substrates for spray deposition of CIGS precursor which consists of In_2S_3 , Cu_2S and Ga [20]. The spray deposition was conducted in ambient atmospheric condition within a fume hood using a glass chromatography atomizer. The targeted film composition based on the CIGS precursor solution with GGI = 0.3 was Cu = 0.9, In = 0.7, Ga = 0.3 and Se = 2. Then, a post-deposition selenization was

performed similarly to the condition mentioned above just that the duration of heating profile used was 50 min.

2. 4 Fabrication of CIGS solar cells

The devices prepared in this project were deposited in standard stack configuration of ZnO:Al/iZnO/CdS/CIGS/Mo/MoO_x/MoC as shown in Figure 2. The substrates used were MoC and the surface of the MoC was oxidized followed by a deposition of a top Mo layer by DC magnetron sputtering. The CdS layer which has a thickness of ~60 nm was deposited via chemical bath deposition. Whereas, the intrinsic ZnO and Al doped ZnO layers which have a thickness of ~80 nm and 500 nm respectively were both deposited using Radio Frequency (RF) sputtering. Mechanical scribing was then carried out to isolate each cell (2.5cm x 2.5cm) into grids with an area of 0.05cm².

Figure 2. CIGS solar cell structure

2. 5 Characterization

A K-Alpha X-ray Photoelectron Spectrometer (XPS) system was used to determine the composition of the surface of the oxidized MoC. The cross-sectional view of the devices was analysed using a Carl Zeiss 1530 VP field emission gun scanning electron microscope (SEM). The aperture size was 30µm and the operating voltage was 5kV. The current density/voltage (J-V) characterization was performed using an in-house solar simulator under 1000W/m² illumination.

3. Results and discussion

3. 1 XPS Analysis

A high resolution XPS analysis was performed on the treated samples in Section 2.1. The results are shown in Table 2. It is shown that the barrier layers formed using the

atmospheric plasma jet contain two types of MoO_x which are MoO_2 and MoO_3 . MoO_2 has been reported as a semiconductor while MoO_3 as an insulator [21]. MoO_2 has previously been used as a barrier layer to block Se diffusion during selenization [22]. However, the ratio of the MoO_x compounds needed and importance of the MoO_3 in the barrier layers are yet to be defined. In Table 2, the reference sample (MoC) has the highest metal atomic percentage and a majority of MoO_2 before undergoing any oxidation process. The samples Mo 1 to Mo 4 have majority of MoO_3 while Mo 3 and Mo 4 have decent amount of MoO_2 . The trend from first set of samples showed that increasing cycle will lead to decrease in amount of MoO_2 and increase in amount of MoO_3 . Increasing oxygen flow rate showed opposite trend which was increased in amount of MoO_2 and decreased in amount of MoO_3 . During the second set samples, increased applied voltages yielded to an initial increase in the amount of MoO_3 from 17.31% to ~24%. Then, a further increase in oxygen flow rate has caused a drastic decrease in MoO_2 content until a point where the surface of sample Mo 8 was almost fully oxidized with very little amount of metal left. Samples Mo 3, 4 and 8 were selected for top Mo layer deposition followed by a less aggressive selenization process for 30 min.

Table 2: High Resolution XPS Summary table

3. 2 SEM analysis on the selenized samples and corresponding devices

SEM analysis was performed on three groups of samples which consist of the untreated samples, sample with Molybdenum Nitride (MoN_x) barrier layer and the samples with MoO_x barrier layers as shown in Figure 3. The area within the dotted line indicated the thickness of MoSe_2 formed. Due to the treatment affecting only the very top surface of the samples, the barrier layers between the MoSe_2 and Mo are hardly to be observed from the SEM images. Nonetheless, the barrier layers were shown to be effective for controlling the formation of MoSe_2 . In Figure 3(a), the entire Mo thickness of the MoC

reacted with Se during the selenization. The thickness of MoSe₂ formed was 2.17μm which is 7 times higher as compare to other samples. The sample in Figure 3(b). which has a configuration of MoC/Mo without any barrier layer showed delamination.

Figure 3. SEM cross-section images for samples (30min selenization) (a) MoC (untreated sample) (b) MoC/Mo (untreated sample) (c) MoN_x barrier layer (d) Mo 3 (e) Mo 4 (f) Mo 8

Result in Figure 3(c). corresponded to the sample with Molybdenum Nitride (MoN_x) barrier layer. The inclusion of the respective result was intended to make a comparison between different types of barrier layers formed in different condition such as atmospheric based and vacuum based process. The MoN_x barrier layer between MoSe₂ and Mo in Figure 3(c). was formed using the DC magnetron sputtering system (vacuum based) with argon to nitrogen gas flow rate of 10:5 SCCM for 2 min. The MoN_x barrier layer was used effectively to control the formation of MoSe₂ to 300nm at the same time the bottom Mo layer was remained unreacted to selenium. Samples from (d) - (f) which have the MoO_x barrier layers worked accordingly to control the formation of MoSe₂. The platelets formation on the surface of Figure 3(d). and (f) samples were due to non-uniformities of the MoSe₂ layer. From Figure 3(d). to (e)., the thickness of MoSe₂ reduction was due to the longer oxidation duration (thicker MoO_x barrier layer). In sample (f), the thickness of MoSe₂ does not reduce further despite using a higher oxygen flow rate during the oxidation process. Hence, the reduction of the MoSe₂ thickness with MoO_x barrier layer was attributed to the increase in the number of oxidation cycle but not the oxygen flow rate.

The cross-section SEM images of the corresponding solar cells (devices) are shown in Figure 4. Referring to Figure 4(a)., excessive formation of MoSe₂

was observed in the untreated device (MoC). Whereas in the untreated device in Figure 4(b). (MoC/Mo), the MoSe₂ was controlled at 210nm. This could be due to the surface of MoC being partly oxidized prior to any oxidation process. Devices in Figure 4(c). with MoN_x barrier layers and (d) and (e) with MoO_x barrier layers were able to control the formation of the MoSe₂ layer while passivating the bottom Mo layer against selenization. On the other hand, barrier layer Mo 8 that has only MoO₃ possessed an excessive formation of MoSe₂ as shown in Figure 4(f). This result has shown that a thin layer of MoO₃ alone is insufficient to suppress the formation of MoSe₂. Among all devices, device Mo 3 with MoO_x barrier layer (5.78% of MoO₂ and 16.94% of MoO₃ which means ratio of MoO₂:MoO₃ is 1:3) has the least MoSe₂ formed which is ~170nm. To further explain this behaviour, the following reactions and their corresponding Gibbs free energy were calculated from [23]:

On the untreated device in Figure 4 (a)., the excessive formation of MoSe₂ layer was caused by reaction 1 during selenization process. At 800K, both reaction 2 and 3 of Mo with O₂ and O₃ have lower Gibbs free energy than reaction 1. The lower the Gibbs free energy, more likely the reaction will take

place. The positive value for Gibbs free energy for the latter case (Reaction 4) shows that the MoO_x barrier layer with both MoO_2 and MoO_3 can act effectively as a diffusion barrier to control the formation of MoSe_2 .

Figure 4. SEM cross-section images for devices (50min selenization) (a) MoC (untreated sample) (b) MoC/Mo (untreated sample) (c) MoN_x barrier layer (d) Mo 3 (e) Mo 4 (f) Mo 8

3. 3 Statistical analysis of the devices

The J-V characteristics measured from 6 solar cells of each sample (0.25cm^2) have been organized into box plots as shown in Figure 5. The average efficiency of the MoC, MoC/Mo, MoN, Mo 3, Mo 4 and Mo 8 devices are 4.45%, 5.07%, 4.2%, 5.24%, 4.13% and 4.19% respectively. In Figure 5., the performance of the device MoC was decent in terms of its fill factor (FF), open circuit voltage (V_{oc}) with an average efficiency of 4.45%. However, the main issue of the MoC device is excessive formation of the MoSe_2 causing delamination problem which deteriorates the electrical properties of the device (possess low J_{sc}). For the device MoC/Mo, its efficiency fluctuated between 4.5% - 5.95%. The large efficiency deviation occurred is due to uneven formation of the MoSe_2 that lead to some of the Se reacted with the bottom Mo layer. This showed that the untreated device MoC/Mo without any MoO_x barrier layer was not able to suppress the growth of MoSe_2 uniformly. In addition, it should be noted that precise control of efficiency in small area devices is a crucial aspect to be considered before moving into large scale production [24]. Although device MoN_x has a consistent efficiency but the efficiency is relatively low at 4.01% - 4.28% as compared to other devices. MoN_x device with lowest J_{sc} obtained is the main factor that affects the efficiency of the device despite having high V_{oc} and decent FF. This case also indicated that the MoN_x barrier layer is very resistive by having

a high series resistance (R_s). For the champion device Mo 3 with 5.78% of MoO_2 and 16.94% of MoO_3 , the contribution made is mainly on uniformity and thinnest formation of MoSe_2 layer (170nm) which eventually lead to highest FF obtained and improved in V_{oc} as compared to the devices with MoN_x barrier layer and devices without barrier layer. The bad performance on device Mo 4 with low FF was caused by a thicker MoO_x barrier layer formed (resistive). The MoO_x barrier in device Mo 4 was formed with more oxidation cycles. Whereas device Mo 8 with low FF and low V_{oc} was due to excessive formation of MoSe_2 .

Figure 5. Box plot of the devices (a) Efficiency (b) Fill factor (FF) (c) V_{oc} (d) J_{sc}

4. Conclusion

During the selenization process, high temperature condition will lead to excessive formation of MoSe_2 which deteriorates the electrical properties of the solar cells. Atmospheric plasma jet can be used to form the MoO_x barrier layer which can effectively suppress the growth of MoSe_2 and improve the efficiency of the solar cells in terms of J-V characteristics. Atmospheric plasma jet oxidizing condition using cycle of 3, He flow rate of 3 SLM, O_2 flow rate of 40 SCCM, frequency of 37.8kHz and p-p voltage of 13.4kV is able to form a MoO_x barrier layer with 5.78% of MoO_2 and 16.94% of MoO_3 . This MoO_x barrier in device Mo 3 with MoO_x ratio of 1:3 (MoO_2 : MoO_3) has proven its ability to control the formation of the MoSe_2 to 170nm which was thinnest among all devices while preventing the bottom Mo layer to react with Se. The passivation effect occurred was due to the reaction between selenium and MoO_2 and MoO_3 (present in the MoO_x) being thermodynamically unfavourable at 800K. The effect of MoO_x barrier on the efficiency and electrical properties of the complete devices have also been examined. The controlled thickness of MoSe_2 in device Mo 3 has achieved the highest efficiency of 5.24% with least efficiency variation. The contribution is mainly on highest FF obtained

and improved V_{oc} as compared to the device with MoN_x barrier layer and devices without barrier layer. Lastly, the conducted experiment has successfully verified the importance, practicality and potential of the surface oxidation MoO_x barrier formed under atmospheric based condition to control $MoSe_2$ formation, improve electrical properties (V_{oc} and FF) and provide a more precise and less variation efficiency on small area devices which is crucial before manufacturing CIGS into large scale production.

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Tables

Table 1: Atmospheric Plasma Jet Oxidizing Condition

Sample Name	Cycle	He Flow (SLM)	O ₂ Flow (SCCM)	Frequency (kHz)	p-p Voltage (kV)
First Set					
Mo 1	3	3	20	37.8	13.4
Mo 2	6	3	20	37.8	13.4
Mo 3	3	3	40	37.8	13.4
Mo 4	6	3	40	37.8	13.4
Second Set					
Mo 5	3	3	40	34.55	21.4
Mo 6	3	3	40	32.6	26.2
Mo 7	3	3	50	32.6	26.2
Mo 8	3	3	60	32.6	26.2

Table 2: High Resolution XPS Summary table

Sample Name	Me (%)	MoO ₂ (%)	MoO ₃ (%)	O1s (%)
MoC (Ref)	46.19	23.53	11.65	18.63
First Set				
Mo 1	7.68	2.23	22.16	67.92
Mo 2	8.15	1.89	22.63	67.32
Mo 3	13.88	5.78	16.94	63.4
Mo 4	11.4	5.27	17.31	66.02
Second Set				
Mo 5	5.6	3	24.14	67.26
Mo 6	3.49	2.53	24.87	69.11
Mo 7	2.81	2.08	25.98	69.13
Mo 8	1.53	0	24.86	73.62

*Me is Molybdenum metal

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